



DOCKET NO: 245112US2DIV

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
TAKASHI IPPOSHI, ET AL. : EXAMINER: TRAN, THIEN F
SERIAL NO: 10/713,044 :
RCE FILED: OCTOBER 27, 2005 : GROUP ART UNIT: 2811
FOR: SEMICONDUCTOR DEVICE FOR :
LIMITING LEAKAGE CURRENT

REQUEST FOR RECONSIDERATION

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated November 16, 2005, please amend the above-identified application as follows:

Remarks/Arguments begin on page 2 of this paper.